Form PTO-1449		Atty Docket No.		Serial No.
		GK0012RI		10/825,670

INFORMATION DISCLOSURE CITATION

IN AN APPLICATION

(Use several sheets if necessary)

Applicant(s)
Won Sun Shin et al.

Filing Date	Group
April 14, 2004	2818

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
/C.L./	AA	4,398,235	08/1983	Lutz et al.	361	393	
/C.L./	AB	4,729,061	03/1988	Brown	361	386	
/C.L./	AC	5,241,133	08/1993	Mullen, III et al.	174	52.4	
/C.L./	AD	5,394,010	02/1995	Tazawa et al.	257	686	
/C.L./	AE	5,438,224	08/1995	Papageorge et al.	257	777	
/C.L./	AF	5,491,612	02/1996	Nicewarner, Jr.	361	760	
/C.L./	AG	5,594,275	01/1997	Kwon et al.	257	686	
/C.L./	AH	5,625,221	04/1997	Kim et al.	257	686	
/C.L./	AI	5,677,569	10/1997	Choi et al.	257	686	
/C.L./	AJ	5,744,827	04/1998	Jeong et al.	257	686	
/C.L./	AK	5,760,471	06/1998	Fujisawa et al.	257	692	

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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	NO
/C.L./	AL	KR1996-0009776	4/01/1996	Rep. Of Korea			abst	
/C.L./	AM	KR1996-041464	9/21/1996	Rep. Of Korea			abst	
	AN							
	AO							
	AP							

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/C.L./	AR	Shin et al., U.S. Patent Application Serial No.10/785528, filed February 24, 2004, entitled "SEMICONDUCTOR PACKAGE AND METHOD FOR FABRICATING THE SAME"
	AS	
	AT	

Examiner	/Chuong Luu/	Date Considered	6/01/2005

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

Form PTO-1449		Atty Docket No. GK0012RI		Serial No. 10/825,670	

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Applicant(s) Won Sun Shin et al.	
Filing Date April 14, 2004	Group 2818

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CAL	AA	5,801,439	09/1998	Fujisawa et al.	257	686	
	AB	5,835,988	11/1998	Ishii	257	684	
	AC	5,866,949	02/1999	Schueller	257	778	
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	AJ	6,313,522	11/2001	Akram et al.	257	686	
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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
	AL							
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	AN							
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	AP							

OTHER DOCUMENTS (*Including Author, Title, Date, Pertinent Pages, Etc.*)

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		Won Sun Shin et al.	
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
CAL	AA	6,395,578	05/2002	Shin et al.	438	106	
	AB	6,396,143	05/2002	Kimbara et al.	257	712	
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CAL	AE	6,577,013	06/2003	Glenn et al.	257	777	
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

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